

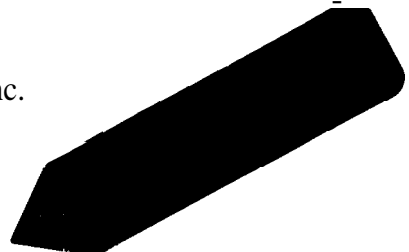
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INTEGRATED ENVIRONMENTAL MONITORING SYSTEM FOR SPACECRAFT

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1, ABSTRACT

This paper describes an integrated space environmental monitoring system for geosynchronous satellites. The system provides measurements of surface charging, internal charging, and total dose radiation from the space environment. This system has been installed on one of Martin Marietta's commercial communications spacecraft, which is scheduled for launch in the near future. There are two components: an integrated charge monitor; which provides total dose and internal charging flux information, and a surface charge detector. Weight is less than one pound; power consumption, about 0.5 watts. Charging flux information from these detectors will permit evaluation of the effects of internal charging on electronic PC boards and will lead to the development of reliable, low-weight methods to detect on-orbit spacecraft charging events and to control charging and discharging.

2, INTRODUCTION

The uncertainties in predicting the effects of energetic particles on satellite systems remain a concern to all spacecraft designers and users. To assist the development of effective mitigation techniques, a lightweight, low-power monitoring system has been designed and built by Martin Marietta Astro Space (now a division of Lockheed Martin) and Jet Propulsion Laboratory. The system consists of two types of instruments -- (1) a radiation dosimeter calibrated to measure internal charging and (2) a surface charging detector. Both instruments will produce continuous telemetry data throughout the mission.

The system will provide a means of monitoring external and internal charging events aboard satellites, which will be very useful in determining the effectiveness of surface ESD control measures, such as conductive coatings, and of protective measures, such as grounded metal shielding, developed for mitigating internal charging effects on PC boards and cables. These evaluations will point the way to future design solutions and to the development of realistic design requirements for control of surface charging and internal charging.

The surface charging monitor was designed to measure charging by magnetospheric plasma electrons with energies from 5 keV to 20 keV and with worst-case current density from 0.1 to 1 nA/cm². The charge monitor will indicate when such an environment is present at the spacecraft's orbital location. Two of these units have been mounted in different places on one of Martin Marietta's commercial communications satellites scheduled for launch in the near future.

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The internal charging detector was designed to monitor flux of, and total dose imparted by, electrons with energies from 200 keV to 6 MeV. This detector will indicate when such an environment is present at the spacecraft's orbital location and will measure the flux of these electrons at various locations inside the spacecraft structure. The key component is a dosimeter designed, fabricated, and tested by the Center for Space Microelectronics Technology, Jet Propulsion Laboratory of the California Institute of Technology [1, 2]. Two of these units have also been mounted on the Martin Marietta satellite.

3. DESIGN DESCRIPTION

3.1. Surface Charging Detector

The surface charge detector has two components -- the charging plate and the associated control electronics. The charging plate is mounted to the spacecraft structure outside the spacecraft and is exposed directly to the space environment. The control electronics unit operates from the +/- 15 volt power lines. It is located inside the spacecraft with the charging plate connected to the input of the instrumentation operational amplifier through a high-input impedance buffering RC circuit as shown in Figure 1. The operational amplifier was configured to provide a 0- to 5-volt output compatible with the standard telemetry format.

Three critical choices during the design of the detector were: charging plate surface material, charging plate substrate, and mounting adhesive. The selection parameters for the surface material and mounting adhesive included electrical conductivity, high voltage leakage current, thermal expansion coefficient, thermo-optical properties, and space environmental stability in the operational temperature range. Surface materials that were considered for the charging plate included S13GLO white paint, Z306 Chemglaze black paint, black anodize, and alumina. Adhesives included RTV 566, CV2946, CV2943, and alumina-loaded Solithane 113. All candidate surface materials and adhesives were tested in a monoenergetic electron beam for their charging potentials, charging and discharging time constants, and compatibility with the readout circuits. A detailed description of the test procedure and test facilities is given in [3-5].

The result of the selection process is a charge collector in the form of a 2" by 2" aluminum plate painted with Chemglaze 2306 dielectric paint bonded to the spacecraft with non-conductive CV2946 adhesive. The plate is charged by impinging electrons. The charging potential on the painted surface can vary from slightly positive to several hundred volts negative, with a corresponding potential on the underlying aluminum plate varying from +5 to -25 volts. This is the result of dividing the surface-to-ground voltage between the two series capacitors in Fig. 1.

The sensor was calibrated with 5-KeV, 10-KeV, and 20-KeV electron beams (beam current densities from 0.25 nA/cm² to 1 nA/cm²) over a -400 C to 600 C temperature range. Typical calibration curves are shown in Figure 2. Several qualification tests were performed on all sensors prior to their integration into the spacecraft. These tests included radiation testing (400 megarads total dose) and thermal cycling (5000 cycles from +60° C to -600 C) on the charge plate; also radiation testing to a total dose of 30 kilorads on the readout circuit. ESD and DC overvoltage tests were also conducted on the readout circuit.

3.2. Dosimeter/Internal Charge Monitor

The dosimeter within the charge monitor comprises four identical radiation-sensitive p-FETs each shielded with a different-thickness Kovar lid. The thinly shielded transistors correspond to components near the surface of a spacecraft; the thickly shielded transistors, to components deep within the spacecraft. Shield thicknesses were selected by trading FET lifetime vs. sensitivity to dose. The directly sensed quantity is ON-channel voltage drop at the temperature-independent current. This is related by calibration to total dose. Total dose can then be related by calculation to incident electron fluence. Differentiating the fluence with respect to time gives charging flux.

The outermost transistors have a higher charge rate, which leads to better resolution, but, since the ON-channel voltage drop saturates at a certain total dose, this also leads to shorter lifetime. That is, the outermost transistors will probably saturate before the end of the satellite's mission,

The microchip layout developed on this effort is shown in Figure 3. It consists of seven components listed in Table 1 including p-FETs PO, PI, P2, and P7, each with different shields. These shields were fabricated in the Kovar lid by chemical etching. The microchip, shown in Fig. 3, was fabricated in a 1.2- μm CMOS rad-soft process. The chip was packaged in a 16-pin flat pack. The equivalent circuit for the chip, shown in Fig. 4, has a multiplexer and decoder used to place each component selectively in the feedback loop of the operational amplifier circuit shown in Fig. 5. The circuitry was designed to force a current at the temperature independent point through the p-FET during measurement. When not operating, the p-FETs are unbiased.

The calibration of the p-FET must account for both dose and temperature effects. The analog voltage, VA, shown in Fig. 5 is :

$$V_A(T, D) = V_{A00} + V_{AT}(T - T_0) + V_{OD} \cdot G \cdot D \quad (1)$$

where V_{A00} is the initial output voltage determined from ground tests, V_{AT} is the temperature coefficient determined from g-round test data, V_{OD} is the dose coefficient determined from Co-60 ground tests, $G = \text{Gain} \approx R_{13}/R_{12}$, and $T_0 = 27^\circ\text{C}$. D is the dose in kilorads; T is the temperature in K. The dose is calculated from :

$$D = [V_A - V_{A00} - V_{AT}(T - T_0)] / (V_{OD} \cdot G) \quad (2)$$

The output voltage, VO, for the p-FET follows from the square law behavior of the FET operating in saturation [11]:

$$V_O = V_T - (2 \cdot I_D / \beta)^{1/2} \quad (3)$$

where V_T is the threshold voltage, β is the transconductance, and I_D is the drain current chosen at the temperature independent point. This expression is used to determine the VO-dose calibration curve given V_T , β , and I_D as discussed below.

The temperature-dose expression for the V_T is:

$$V_T = V_{T00} + V_{TT}(T - T_0) + \Delta V_T [1 - \exp(-D/D_0)] \quad (4)$$

where V_{T00} is the threshold voltage at T_0 and $D=0$, V_{TT} is the threshold voltage temperature coefficient, D_0 is the V_T dose coefficient, and ΔV_T is the maximum change in V_T when the radiation reaches infinity. When $D = D_0$ and at constant T , the V_T increases by $\Delta V_T [1 - 1/e]$. The expression for V_T indicates that V_T is rate limited, which depends on the filling of a finite supply of gate-oxide hole traps [6]. The V_T equation was solved using the least-squares method to determine V_{T00} , V_{TT} , and ΔV_T . The parameter D_0 was found using an optimization technique that maximizes the least-squares correlation coefficient.

The dose-temperature expression for β is :

$$\beta = \beta_{00} (T/T_0)^{-n} / [1 + (D/D_0) \times (T/T_0)^{-n}] \quad (5)$$

where β_{00} is β evaluated at T_0 and $D=0$, n is the β temperature coefficient and D_m is the β or mobility dose coefficient, When $D = D_m$ at $T = T_0$, then β is reduced by 50%. This equation was formulated by combining the β temperature and dose dependence as the sum of reciprocals.

The p-FET drain current at the temperature independent operating point, I_{Dm} , is found by differentiating the VO expression with respect to temperature. Setting the resulting expression equal to zero at the measurement temperature, T_m (which is the expected on-orbit operating temperature), and $D=0$ leads to [6]:

$$I_{Dm} = 2(\beta_{m0})^2 (-VT_T/\beta T_{m0})^2 \quad (6)$$

where $\beta T_{m0} = (-n/T_m)\beta_{m0}$, $\beta_{m0} = (T_m/T_0)^{-n}$.

The V_T , β , and VO results are presented graphically in Figs. 6 to 8. The curves were obtained by fitting the data shown in Fig. 6 to Eq. 4 and the data shown in Fig. 7 to Eq. 5. Thus, the p-FET results can be characterized by seven parameters, namely V_{T00} , V_T , ΔV_T , D_0 , β_{00} , n and D_m . These parameters are listed in Table 2 for transistor P0. The device-to-device uniformity was excellent,

VO values were obtained from Eq. 3 using Eq. 4 for V_T , Eq. 5 for β , and Eq. 6 for I_{Dm} . The $V_{O_{m0}}$ values listed in Table 5 for each of the four p-FETs, are within 0.1% of each other. The VO values are plotted in Fig. 8 for two different values of $I_{D_{m0}}$. The curves for the P0 design value of $I_{D_{m0}} = 88 \mu A$ show that VO is fully temperature compensated at $D=0$. The curves for the operating value $I_{D_{m0}} = 100 mA$ show that temperature compensation occurs near 100 krad and that $V_{O_{m0}} = 1.57 V$. These parameters were used as the target design parameters, thus the 100 mA curve is designated as the calibration curve. The samples from the flight lot of dosimeters were radiation tested and calibrated using a Co-60 gamma source at -25C, +10C and 45 C. A burn-in test, centrifuging and temperature cycling tested were also performed on the flight devices,

A similarly fabricated p-FET was flown on STRV-1b, launched June 17, 1994 into a 10.59-hr orbit. The p-FET temperature dependence was determined from the slope of the flight data as shown in Fig. 9. The dose for the STRV-1b is shown in Fig. 10. It shows the dose at different locations and behind different shields in the JPL experiment box. The results indicate that dose is not uniform across the exposed portion of the box.

4. SPACECRAFT IMPLEMENTATION

As stated above, two surface charge monitors and two dosimeters have been installed on a Martin Marietta commercial communications satellite. Total weight of the system is less than one pound and it requires approximately 0.5 watts of power.

Surface charge monitors were installed on the north and anti-earth panels. The sensor located on the north panel will be continuously shadowed for a period of six months; then it will be continuously exposed to sunlight during the other six months; it will provide data on seasonal variations of spacecraft charging potential. The sensor mounted on the anti-earth panel will be moving in and out of the sunlight on the daily basis; it will provide data on daily variations in spacecraft charging potential.

In addition, two dosimeters will be used to monitor internal charging fluxes and total dose accumulation. One dosimeter was mounted on the north panel internal to the spacecraft structure with the sensor facing the panel. In addition to its Kovar lid, this sensor is shielded from external radiation by the spacecraft panel. This location is typical for most spacecraft components. The second dosimeter is located outside the spacecraft structure on the anti-earth

panel. In addition to the Kovar lid, this sensor is shielded from external radiation by a ten layer Kapton thermal blanket. Thus a total of eight p-FETs with different shield thicknesses will provide electron flux count in eight energy channels,

Support logic is combined with the sensors in order to meet the spacecraft's interface requirements. The sensors were tested for functional performance following their installation on the spacecraft and during spacecraft level thermal testing.

5. CONCLUSIONS

Development of mitigation techniques for spacecraft charging control requires thorough knowledge of the environmental conditions and of their impact on spacecraft components. An integrated space environmental monitoring system has been developed, built, and installed on a geosynchronous communications satellite. Its low weight and power requirements allow easy incorporation into the spacecraft design, satellite performance can be correlated with in-situ charging and dose rate. Until now, the only environmental data available was from research satellites, in different time zones and along different flux tubes. We envision that in the future, such systems may become a standard part of the bus telemetry as common as temperature sensors for all geosynchronous spacecraft.

6. ACKNOWLEDGMENTS

This effort was sponsored by Martin Marietta's Independent Research and Development program and by the Ballistic Missile and Defense Organization, Innovative Science and Technology office. Dosimeters were developed and tested by the Center for Space Microelectronics, Jet Propulsion Laboratory, California Institute of Technology. The devices used in this study were fabricated through MOSIS, Information Sciences Institute, University of Southern California,

7. REFERENCES

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Table 1. Microchip Devices

DEVICE	TYPE	SHIELD (mil)
P0	GATE OXIDE p-FET	6
P1	GATE OXIDE p-FET	0
P2	GATE OXIDE p-FET	2
P7	GATE OXIDE p-FET	10
N3	FIELD OXIDE n-FET	not used
N5	GATE OXIDE n-FET	not used
R4	METAL-1 RESISTOR	70
E6	EXTERNAL DEVICE	NA

Table 2, P-FET Design Parameters

PARAMETER	DESCRIPTION	UNITS	VALUE
T_0	Reference value of temperature	$^{\circ}\text{C}$	27
T_m	On-orbit avalue of temperature	$^{\circ}\text{C}$	10
V_{T0}	Threshold voltage @ zero dose & T_0	V	-0.8598
V_{T_T}	$\partial V_T / \partial T$ at constant dose D	mV/ $^{\circ}\text{C}$	1.7595
ΔV_T	Saturation value of change in V_T by dose D	V	-0.4998
D_0	Value of D at which V_{T0} has increased by $\Delta V_T [1-1/e]$	kilorads	118.91
β_{00}	channel transconductance	$\mu\text{A}/\text{V}^2$	474.73
D_m	dose coefficient of β in eqn (5)	kilorads	588.5
n	temperature coefficient of β in eq. (5)		1.7196
I_{Dm0}	Design value of temperature-independent drain current	μA	prelim.: 88,36; final: 100
V_{Omo}	Output voltage	V	prelim.: -1.47 final: -1.507

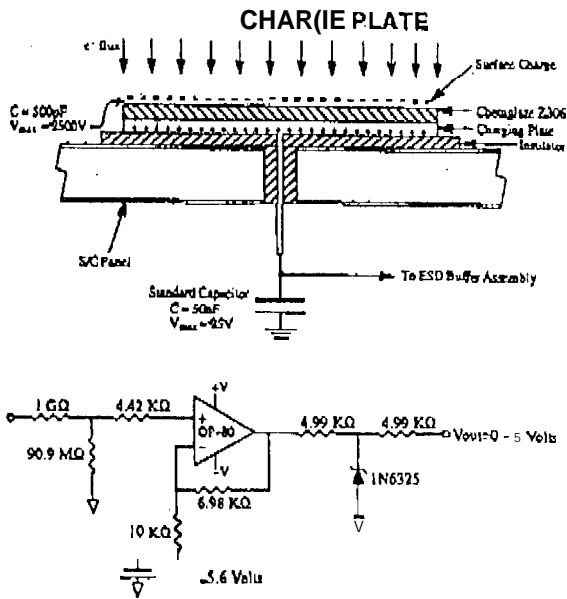


Figure 1. Surface Charging Sensor Description

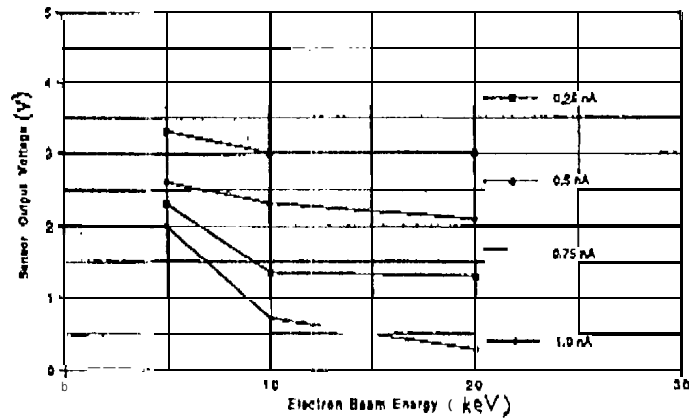


Figure 2. Surface Charging Sensor Calibration (T=25°C)

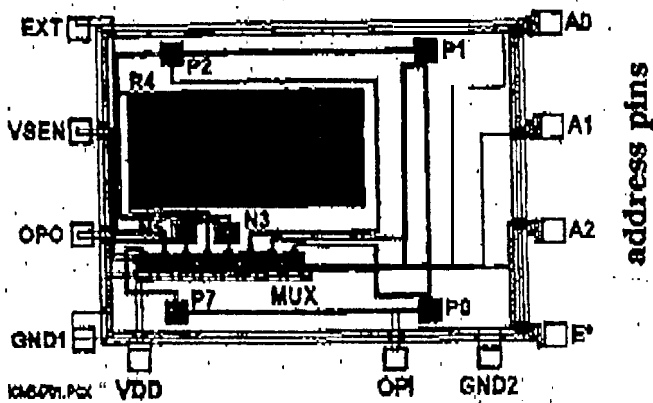
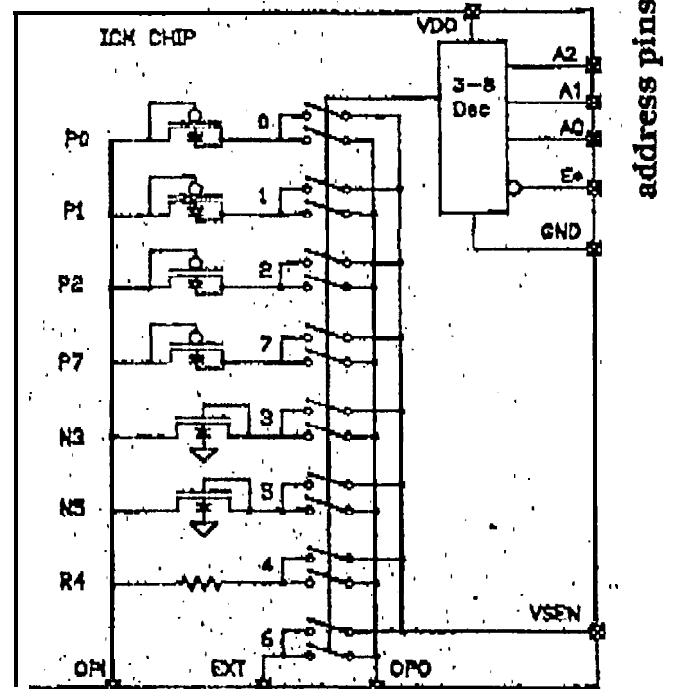


Figure 3. Microchip with four p-FETs, P1, P2, P7, and P8. Each p-FET is located behind a different shield whose thickness is listed in Table 1. The different shield thicknesses were obtained by selectively chem-etching the Kovar lid.



1044713.MLT
Figure 4. Microchip schematic.

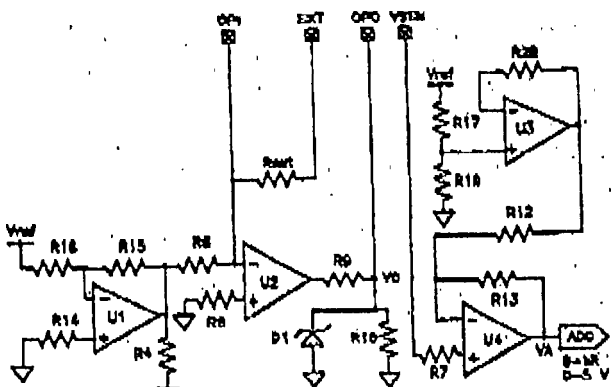


Figure 5. Microchip surround circuitry.

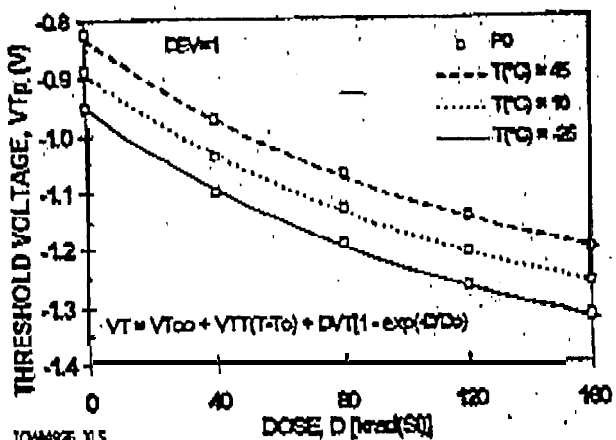


Figure 6. p-FET threshold voltage dose-temperature fit to Eq. 4.

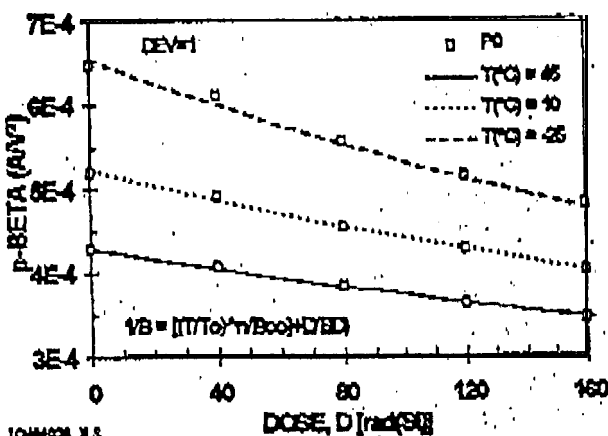


Figure 7. p-FET beta dose temperature fit to Eq. 5.

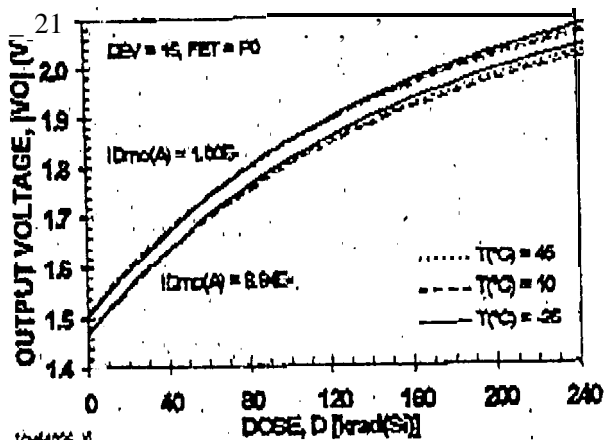


Figure 8. p-FET output voltage dose dependence.

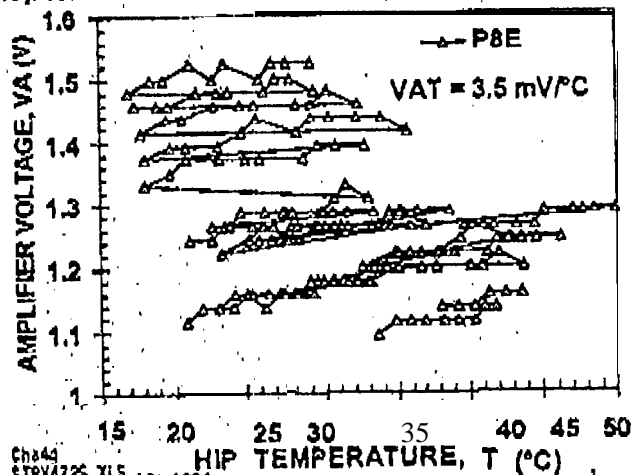


Figure 9. STRV-1b p-FET VA-temperature dependence, $V_{AT} = 3.5 \text{ mV/}^\circ\text{C}$.

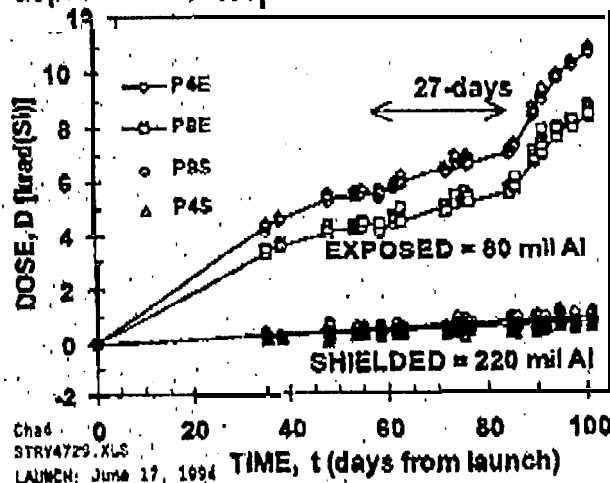


Figure 10. STRB-1 b dose profile for devices behind 80-mm and 220-mm Al shields.